Docket No.: 2336-242 PATENT

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Inventor: Sun Woon KIM : Confirmation No. Not yet assigned

U.S. Patent Application No.: Not yet assigned : Group Art Unit: Not yet assigned

Filed: Herewith

For: NITRIDE-BASED SEMICONDUCTOR DEVICE

## **INFORMATION DISCLOSURE STATEMENT**

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached form PTO-1449. It is respectfully requested that the documents be expressly considered during the prosecution of this application, and that the documents be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed within three months of the U.S. filing date OR before the mailing date of a first Office Action on the merits. No certification or fee is required.

Respectfully submitted,

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BJH/etp

## ATTY. DOCKET NO. U.S. APPLICATION NO. 2336-242 Not yet assigned INFORMATION DISCLOSURE **APPLICANT** CITATION IN AN Sun Woon KIM **APPLICATION** FILING DATE **GROUP** herewith (PTO-1449) **U.S. PATENT DOCUMENTS EXAMINER'S** FILING DATE CLASS **SUBCLASS INITIALS** PATENT NO. NAME DATE FOREIGN PATENT DOCUMENTS **EXAMINER'S** Translation PATENT NO. DATE COUNTRY **CLASS SUBCLASS** Yes No INITIALS WO 00/76004 A1 12/2000 **WIPO** Abstract OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.) "Spiral Growth of IngaN Nanoscale Islands on GaN" by Keller et al.; Japanese Journal of Applied Physics, Vol. 37, pgs. L431-434, c. 1998

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.

DATE CONSIDERED

**EXAMINER**